



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 9071

SERIAL NUMBER 10/625,407	FILING DATE 07/23/2003 RULE	CLASS 219	GROUP ART UNIT 3742	ATTORNEY DOCKET NO. TWI-8570
-----------------------------	---------------------------------------	--------------	------------------------	------------------------------------

APPLICANTS

Michial Duff Howell, Felton, CA;

Barry Roy Bowman, Dublin, CA;

**** CONTINUING DATA *******

This application is a CON of 09/859,917 05/17/2001 PAT 6,624,393
which is a DIV of 09/499,478 02/07/2000 PAT 6,261,853

**** FOREIGN APPLICATIONS *******

IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **

** 03/23/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 8	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials				

ADDRESS

STALLMAN & POLLOCK LLP
Suite 290
121 Spear Street
San Francisco, CA
94105

TITLE

Method and apparatus for preparing semiconductor wafers for measurement

FILING FEE RECEIVED 375	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other
-----------------------------------	---	--

	<input type="checkbox"/> Credit
--	---------------------------------